

Luo Cheng Huang

Graduate Researcher

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Education

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| Sep 2019 – Ongoing | University of Washington, Seattle <i>Ph.D. in Electrical and Computer Engineering</i> |
| Jun 2017 – Sep 2019 | University of Washington, Seattle <i>Master of Science in Materials Science and Engineering</i> |
| Sep 2013 – Jun 2017 | University of Washington, Seattle <i>Bachelor of Science in Materials Science and Engineering</i> |

Experience

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| Oct 2017 – Jun 2018 | University of Washington – DIRECT Program <i>Trainee</i> <ul style="list-style-type: none">Developed Thermoelectric Materials Artificial Neural Network (TEMANN), a python package that can be used to predict Seebeck coefficients for novel materials. Link to GithubCompleted courses on various topics concerning artificial neural networks including architectures, hyperparameter tuning, regularization, optimization, etc. |
| Jul 2018 – Jun 2019 | American Institutional Assets, Seattle <i>Intern</i> <ul style="list-style-type: none">Successfully developed an organic liquid fertilizer that has anti-bacterial, anti-fungal, and anti-parasitic properties. Also drip irrigation compatible. |

Leadership and Teaching Experience

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| Sep 2019 – Jun 2021 | University of Washington, Seattle <i>Teaching assistant</i> <ul style="list-style-type: none">Held quiz sections and office hours for EE215 and EE299. |
| Sep 2016 – Jun 2017 | American Ceramic Society – Keramos UW Chapter <i>President</i> <ul style="list-style-type: none">Organized weekly meetings, and coordinated outreach events. |

Technical Skills

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| Programming | Python, MATLAB, Java, JavaScript, HTML/CSS, L ^A T _E X |
| Frameworks | Proxmox, HAProxy, Tensorflow |
| Softwares | Zemax OpticStudio, SolidWorks |
| Fabrication | ABM Semi-Auto aligner, Heidelberg DWL66 ⁺ , spin coater, Profilometer (DektakXT), EBeam Lithography (JBX6300FS), ellipsometer (Woollam Alpha SE), SEM, Optical Microscopy, Quorum sputter coater, E-beam Evaporator (SEC-600), ICP-Fluorine etcher, Evatec LLS EVO Sputter System, Barrel Asher, SPTS PECVD, Disco Wafer Dicer. |

Honors

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| 2016 | Livingston Wernecke Memorial Scholarship, UW James I. Mueller Scholarship, UW |
| 2014 | Composers Guild 44 th Annual Composition Contest, Utah Utah Best of Young Composer & 2nd Prize & Best of Age Group, Utah |
| 2013 | National Scholastic Art & Writing Silver Medalist, New York Utah State Math Contest 1st Team Award & Finalist, Utah |

Publications

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| 2021 | <ul style="list-style-type: none">[1] E. Bayati, A. Wolfram, S. Colburn, L. Huang, and A. Majumdar. “Design of achromatic augmented reality visors based on composite metasurfaces”. In: <i>Applied Optics</i> 60.4 (2021), pp. 844–850.[2] L. Huang, Z. Coppens, K. Hallman, Z. Han, K. F. Böhringer, N. Akozbek, A. Raman, and A. Majumdar. “Long wavelength infrared imaging under ambient thermal radiation via an all-silicon metalens”. In: <i>Optical Materials Express</i> 11.9 (2021), pp. 2907–2914.[3] L. Huang, J. Whitehead, S. Colburn, and A. Majumdar. “Extended Depth of Focus Metalenses for Achromatic Computational Imaging”. In: <i>CLEO: Science and Innovations</i>. Optical Society of America. 2021, STh4O–2.[4] E. Tseng, S. Colburn, J. Whitehead, L. Huang, S.-H. Baek, A. Majumdar, and F. Heide. “Neural Nano-Optics for High-quality Thin Lens Imaging”. In: <i>arXiv preprint arXiv:2102.11579</i> (2021).[5] J. E. Whitehead, A. Zhan, S. Colburn, L. Huang, and A. Majumdar. “Fast Extended Depth of Focus Meta-Optics for Varifocal Functionality”. In: <i>arXiv preprint arXiv:2106.15807</i> (2021). |
| 2020 | <ul style="list-style-type: none">[6] L. Huang, J. Whitehead, S. Colburn, and A. Majumdar. “Design and analysis of extended depth of focus metalenses for achromatic computational imaging”. In: <i>Photonics Research</i> 8.10 (2020), pp. 1613–1623. |
| 2018 | <ul style="list-style-type: none">[7] S. Colburn, A. Zhan, E. Bayati, J. Whitehead, A. Ryou, L. Huang, and A. Majumdar. “Broadband transparent and CMOS-compatible flat optics with silicon nitride metasurfaces”. In: <i>Optical Materials Express</i> 8.8 (2018), pp. 2330–2344. |